

L Number	Hits	Search Text	DB	Time stamp
-	2	(titanium near nitride) and (tin or (titanium near nitride)).clm. and (active near matrix).clm. and gate.clm. and electrode.clm. and (TFT or (thin near film near transistor)).clm. and (multilayer or multilevel or multi-layer or multi-level).clm.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 21:02
-	35	(titanium near nitride) and (tin or (titanium near nitride)).clm. and (nitrogen near concentration).clm.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 21:03
-	7	(titanium near nitride) and ((tin or (titanium near nitride)).clm. same (nitrogen near concentration)).clm.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 21:03
-	115	(titanium near nitride) and ((tin or (titanium near nitride)) same (nitrogen near concentration))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 21:03
-	115	(titanium near nitride) and (((tin or (titanium near nitride)) same (nitrogen near concentration)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 21:03
-	3	(titanium near nitride) and (((tin or (titanium near nitride)) same (nitrogen near concentration))) and pixel	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 21:04
-	133	(titanium near nitride) and (((tin or (titanium near nitride)) and (nitrogen near concentration))) and pixel	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 21:04
-	78	(titanium near nitride) and (((tin or (titanium near nitride)) and (nitrogen near concentration))) and pixel.clm.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 21:04
-	9	(titanium near nitride) and (((tin or (titanium near nitride)).clm. and (nitrogen near concentration))) and pixel.clm.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 21:04

L Number	Hits	Search Text	DB	Time stamp
-	7	(multilevel or multi-level or multilayer or multi-layer).clm. and (active near matrix).clm. and (tin or (titanium near nitride)).clm.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 20:53
-	1	(multilevel or multi-level or multilayer or multi-layer).clm. and (active near matrix).clm. and (tin or (titanium near nitride)).clm. and (scan or scanning).clm.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 20:53
-	36	(active near matrix).clm. and (tin or (titanium near nitride)).clm. and (scan or scanning).clm.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 20:53
-	19	(active near matrix).clm. and (tin or (titanium near nitride)).clm. and (scan or scanning).clm. and gate.clm. and electrode.clm. and (tft or (thin near film near transistor)).clm.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 20:54
-	19	(active near matrix).clm. and (tin or (titanium near nitride)).clm. and ((scan or scanning) near2 line).clm. and gate.clm. and electrode.clm. and (tft or (thin near film near transistor)).clm.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 20:55
-	1	(active near matrix).clm. and (tin or (titanium near nitride)).clm. and ((scan or scanning) near2 line).clm. and gate.clm. and electrode.clm. and (tft or (thin near film near transistor)).clm. and (titanium near nitride)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 20:55
-	8	(active near matrix).clm. and (tin or (titanium near nitride)).clm. and ((scan or scanning) near2 line).clm. and gate.clm. and electrode.clm. and (tft or (thin near film near transistor)).clm. and (titanium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/02/21 20:55

L Number	Hits	Search Text	DB	Time stamp
-	299	(active near matrix).ti,ab,clm. and (TFT or (thin near film)).ti,ab,clm. and gate.ti,ab,clm. and ((scan or scanning)).ti,ab,clm.	USPAT; US-PGPUB	2004/02/21 20:43
-	240	(active near matrix).ti,ab,clm. and (TFT or (thin near film)).ti,ab,clm. and gate.ti,ab,clm. and ((scan or scanning)).ti,ab,clm. and electrode.ti,ab,clm.	USPAT; US-PGPUB	2004/02/21 20:43
-	4	(active near matrix).ti,ab,clm. and (TFT or (thin near film)).ti,ab,clm. and gate.ti,ab,clm. and ((scan or scanning)).ti,ab,clm. and electrode.ti,ab,clm. and (nitrogen near concentration).ti,ab,clm.	USPAT; US-PGPUB	2004/02/21 20:45
-	7	(active near matrix).ti,ab,clm. and (TFT or (thin near film)).ti,ab,clm. and gate.ti,ab,clm. and ((scan or scanning)).ti,ab,clm. and electrode.ti,ab,clm. and (nitrogen near concentration)	USPAT; US-PGPUB	2004/02/21 20:45